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<b>APPLICANTS</b> Tsutomu Ogihara, Niigata-ken, JAPAN; Fujio Yagihashi, Niigata-ken, JAPAN; Yoshitaka Hamada, Niigata-ken, JAPAN; Takeshi Asano, Niigata-ken, JAPAN; Motoaki Iwabuchi, Niigata-ken, JAPAN; Hideo Nakagawa, Oumihachiman-shi, JAPAN; Masaru Sasago, Osaka, JAPAN;					
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** FOREIGN APPLICATIONS ..... <i>Yes AICS</i> JAPAN 2003-087066 03/27/2003					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/07/2004					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>Asst. Examiner Sasaki</i> <small>Examiner's Signature</small>		STATE OR COUNTRY JAPAN	SHEETS DRAWING 1	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 2
<b>ADDRESS</b> 00826 ALSTON & BIRD LLP BANK OF AMERICA PLAZA 101 SOUTH TRYON STREET, SUITE 4000 CHARLOTTE , NC 28280-4000					
<b>TITLE</b> Composition for forming porous film, porous film and method for forming the same, interlevel insulator film and semiconductor device					
FILING FEE RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			